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XA-9631

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Hisao YAMAGATA et al.

Serial No.: 10/083,503

Group Art Unit: 2812

Filed: February 27, 2002

Examiner: O. Luk

For: SEMICONDUCTOR DEVICE MANUFACTURING METHOD AND

SEMICONDUCTOR DEVICE SORTING SYSTEM TO BE USED WITH

THE SAME

RESPONSE

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

JUL 21 2003 TECHNOLOGY CENTER 2800

Responding to the Office Action mailed June 27, 2003, and to the requirement for restriction therein, Applicants elect Group I (Claims 1-27) for examination, reserving the right to file a divisional application with regard to the non-elected invention.

An action on the merits of the claims to the elected invention is respectfully requested.

The Commissioner is hereby authorized to charge to

Deposit Account No. 50-1165 any fees under 37 C.F.R. §§1.16

and 1.17 which may be required by this paper, and to credit

any overpayment to that Account. If any extension of time

is required in connection with the filing of this paper and has not been requested separately, then such extension is hereby requested.

Respectfully submitted,

By: full W. Shapiro

Reg. No. 31,568

MWS:lat

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July 16, 2003